



Attorney Docket SEL 144

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
Hiroki Adachi )  
Serial No.: 09/437,649 )  
Filed: November 10, 1999 )  
For: Exposure Device, Exposure Method )  
And Method Of Manufacturing )  
Semiconductor Device )  
Art Unit: 2814 )  
Examiner: S. Rao )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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October 6, 2003  
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 10/6/03  
Signature Date

**AMENDMENT B**

Sir:

In response to the Office Action dated June 4, 2003, a one month extension of time being submitted herewith, please amend the above-identified application as follows:

RECEIVED  
OCT 17 2003  
TECHNOLOGY CENTER 2800